



Docket Number (Optional) NEC NE03P181	Application Number 10/748,821
Applicant(s) OHTO et al.	
Filing Date December 30, 2003	Group Art Unit 2812

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
JS		6,162,743	12.19.00	CHU et al.	438	781	

U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
JS		2001/0004550	6.21.01	PASSEMARD	438	618	

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER 	DATE CONSIDERED 3/1/06
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

(Use several sheets if necessary)

Group Art Unit

[illegible]

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		2001-127159	11.05.2001	JAPAN (w/Abstract)	H01L	21/768		✓
		2002-083870	22.03.2002	JAPAN (w/Abstract)	H01L	21/768		✓
		2002-275631	25.09.2002	JAPAN (w/Abstract)	C23C	16/42		✓
		WO 99/41423	19.08.1999	WIPO	C23C	A2		✓
		WO 00/19498	06.04.2000	WIPO	H01L	21/027		✓

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